

Receipt

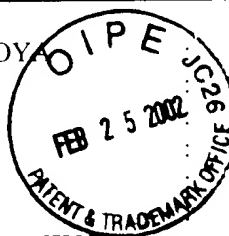
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Shuichi FURUOY

Appln. No.: 09/854,614

Filed: May 14, 2001

For: **APPARATUS FOR SPIN COATING
SEMICONDUCTOR SUBSTRATE AND
METHOD OF DOING THE SAME**



Art Unit: 1762

Examiner: To Be Assigned

Docket No.: APM-01102

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Tracey Newell
Name: Tracey Newell

REQUEST FOR CORRECTION OF FILING RECEIPT

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Sir:

Please make the following correction on the Filing Receipt for the above-captioned application:

In the Domestic Priority data section: remove "ABN"

Please correct the Filing Receipt to reflect this change.

A copy of the Filing Receipt with the change noted in red is also submitted herewith.

Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at (617) 951-6676.

Respectfully submitted,
HUTCHINS, WHEELER & DITTMAR

Donald W. Muirhead
Reg. No. 33,978

February 11, 2002
Date

Patent Group
Hutchins, Wheeler & Dittmar
101 Federal Street
Boston, MA 02110

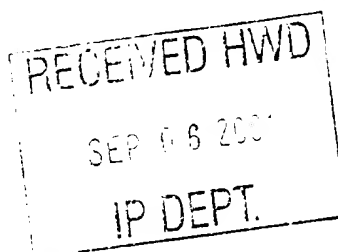


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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/854,614	05/14/2001	1762	710	APM-01102	9	7	1

Patent Group
Hutchins, Wheeler & Dittmar
101 Federal Street
Boston, MA 02110



CONFIRMATION NO. 4827

CORRECTED FILING RECEIPT



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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

Shuichi Furuoya, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A DIV OF 09/453,428 12/02/1999 ABN

Foreign Applications

JAPAN 10-346766 12/07/1998

If Required, Foreign Filing License Granted 07/10/2001

Projected Publication Date: 10/18/2001

Non-Publication Request: No

Early Publication Request: No

Title

Apparatus for spin-coating semiconductor substrate and method of doing the same

Preliminary Class

427

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Bib Data Sheet

CONFIRMATION NO. 4827

SERIAL NUMBER 09/854,614	FILING DATE 05/14/2001 RULE	CLASS 427	GROUP ART UNIT 1762	ATTORNEY DOCKET NO. APM-01102
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APPLICANTS

Shuichi Furuoya, Tokyo, JAPAN;

** CONTINUING DATA *****

THIS APPLICATION IS A DIV OF 09/453,428 12/02/1999 PAT 6,352,589

** FOREIGN APPLICATIONS *****

JAPAN 10-346766 12/07/1998

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/10/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature _____ Initials _____				

ADDRESS

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TITLE

Apparatus for spin-coating semiconductor substrate and method of doing the same

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